



Attorney's Docket No.: 04239CP

Patent

1765
#5/A
SA
9/20/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:)
Anne E. Miller)
U.S. Serial No: 09/715,690) Examiner: Umez Eronini, L.T.
Filed: November 16, 2000) Art Unit: 1765
For: COPPER POLISH SLURRY FOR)
REDUCED INTERLAYER DIELECTRIC)
EROSION AND METHOD OF USING SAME)

Commissioner of
Patents and Trademarks
Washington, D.C. 20231

RESPONSE TO ELECTION REQUIREMENT AND AMENDMENT

Sir:

In response to the Election Requirement mailed September 3, 2002, applicant(s) hereby elects to prosecute Group I claims, claims 1-16 drawn to a slurry. As such, applicant(s) elects to withdraw Group II claims, claims 17-24 drawn to a method of making a slurry and Group II claims, claims 25-30 drawn to a polishing method. Applicant respectfully requests the Examiner to enter the following amendments

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

on September 12, 2002

Date of Deposit

Teresa Edwards

Name of Person Mailing Correspondence

Teresa Edwards
Signature

September 12, 2002
Date

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